Notice of Allowability	Application No.	Applicant(s)
	10/512,408	MUSHIKA, YOSHIHIRO
	Examiner	Art Unit
	Andrew Hwa S. Lee	2886
The MAILING DATE of this communication appeall claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT Report of the Office or upon petition by the applicant. See 37 CFR 1.313	ears on the cover sheet with (OR REMAINS) CLOSED in the or other appropriate communi IGHTS. This application is sub	the correspondence address nis application. If not included cation will be mailed in due course. THIS
1. This communication is responsive to <u>2/14/07</u> .	•	•
2. The allowed claim(s) is/are 2-22.		
 3. Acknowledgment is made of a claim for foreign priority ur a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 		(f) .
Certified copies of the priority documents have 2. Certified copies of the priority documents have		No.
3. Copies of the certified copies of the priority documents have been received in this national stage application from the		
International Bureau (PCT Rule 17.2(a)).		
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file a MENT of this application.	reply complying with the requirements
4. A SUBSTITUTE OATH OR DECLARATION must be subminformal patent application (PTO-152) which giv		
5. CORRECTED DRAWINGS (as "replacement sheets") must be submitted.		
(a) I including changes required by the Notice of Draftspers	son's Patent Drawing Review (PTO-948) attached
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date		
(b) ☐ including changes required by the attached Examiner Paper No./Mail Date		
Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d).		
6. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.		
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Attachment(s) 1. Notice of References Cited (PTO-892)	5. Notice of Info	rmal Patent Application
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. 🗌 Interview Sun	nmary (PTO-413),
3. Information Disclosure Statements (PTO/SB/08),	Paper No./M 7. ☐ Examiner's A	ail Date mendment/Comment
Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit	8. ⊠ Examiner's S	tatement of Reasons for Allowance
of Biological Material	9. 🔲 Other	
		Andrew Hwa S. Lee Primary Examiner Art Unit: 2886

REASONS FOR ALLOWANCE

1. The following is an examiner's statement of reasons for allowance:

With respect to claims 2-4, 8-13, 16-18, 20, and 21, the prior art of record fails to show or suggest an optical detection system having all the elements as presently claimed wherein the photosensor selecting section cyclically switches the photosensitive areas to select by a time sequential technique, and wherein synchronously with this switching operation, the modulation control section provides a modulation pattern, which produces appropriate imaging ability in the photosensitive area selected, for the spatial light modulator.

With respect to claims 5-7, the prior art of record fails to show or suggest an optical detection system having all the elements as presently claimed wherein the incoming light entering the spatial light modulator includes light rays with multiple different wavelengths.

With respect to claim 14, the prior art of record fails to show or suggest an optical detection system having all the elements as presently claimed in combination with a position change detecting section for detecting a change of the position of the optical detection system, wherein in accordance with the output of the position change detecting section, the modulation control section generates a modulation pattern that compensates for a shift in focal point caused by the position change.

With respect to claim 15, the prior art of record fails to show or suggest an optical detection system having all the elements as presently claimed wherein each of the photosensitive areas in the photodetector has a plurality of pixels arranged at a pitch, and

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wherein the modulation control section provides a modulation pattern, which focuses the incoming light at multiple points that are shifted from each other by a distance corresponding to the pixel pitch of the photodetector, for the spatial light modulator.

With respect to claim 19, the prior art of record fails to show or suggest an optical detection system having all the elements as presently claimed wherein the spatial light modulator is a liquid crystal element.

With respect to claim 22, the prior art of record fails to show or suggest an optical detection system having all the elements as presently claimed wherein the spatial light modulator functions as an optical low pass filter.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Andrew Hwa S. Lee whose telephone number is 571-272-2419. The examiner can normally be reached on Tue-Fr.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Tarifur R. Chowdhury can be reached on 571-272-2800. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Andrew Hwa S. Lee Primary Examiner

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